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#12  
6-24-02  
Muller

Docket No. 8733.213.00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Jin JANG et al.

GAU: 2814

SERIAL NO: 09/497,508

EXAMINER: Wai Sing LOUIE

FILED: February 4, 2000

FOR: POLYCRYSTALLINE SILICON FILM CONTAINING NI

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JUN 20 2002  
TECHNOLOGY CENTER 2800

REQUEST FOR EXTENSION OF TIME  
UNDER 37 C.F.R. 1.136

COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231

SIR:

It is hereby requested that a 2-month extension of time be granted to **June 14, 2002** for


- ☐ filing a response to the Official Action dated:
- ☐ responding to the requirements in the Notice of Allowability dated:
- ☐ filing the Formal Drawings. The Issue has been timely filed.  
Fee due
- ☐ responding to the Notice to File Missing Parts of Application dated: \*
- ☒ filing a Notice of Appeal. A timely response to the final rejection, due April 14, 2002 has been filed.
- ☐ filing an Appeal Brief. A Notice of Appeal was filed on:
- ☐

The required fee of **\$400.00** is enclosed herewith by check and any further charges may be made against the Attorney of Record's Deposit Account No. **50-0911**.

Respectfully Submitted,

MCKENNA LONG & ALDRIDGE LLP

Date: June 13, 2002

  
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PATENT TRADEMARK OFFICE